Application/Control No. · Applicant(s)/Patent Under Reexamination 10/797,867 CHEN ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 2822 Monica Lewis **U.S. PATENT DOCUMENTS** Date **Document Number** Classification Name Country Code-Number-Kind Code MM-YYYY 313/582 US-6,806,645 10-2004 Choi, Kwang Yeol Α US-В US-С US-D US-Ε F US-US-G US-Н USł US-J US-Κ US-L US-М **FOREIGN PATENT DOCUMENTS** Date **Document Number** Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U

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